Application/Control No.	Applicant(s)/Patent under Reexamination	
10/522,577	TAKAHASHI ET AL.	
Examiner	Art Unit	
Chau N. Nguyen	2831	

	SEAR	SEARCHED			
Class	Subclass	Date	Examiner		
174	106R	12/16/2005	CN		
	108				
174	36	9/27/2006	CN		
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Class	Subclass	Date	Examiner		
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		9/28/2007	CN		

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		DATE	EXMR
Text		12/16/2005	CN
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